## Notice of References Cited Application/Control No. 10/689,690 Examiner DeWanda Samuel Applicant(s)/Patent Under Reexamination UN ET AL. Art Unit Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2003/0149746	08-2003	Baldwin et al.	709/219
*	В	US-6,118,785	09-2000	Araujo et al.	370/401
*	C	US-7,117,530	10-2006	Lin, Yeejang James	726/15
*	D	US-2003/0078996	04-2003	Baldwin, David A.	709/220
*	Е	US-6,226,751	05-2001	Arrow et al.	726/15
*	F	US-6,295,293	09-2001	Tonnby et al.	370/389
*	G	US-5,930,258	07-1999	Dato Solis et al.	370/401
*	Н	US-6,985,935	01-2006	Zhang et al.	709/219
*	I	US-6,426,950	07-2002	Mistry, Dhansukh Nathubhai	370/352
	J	US-			
	К	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Z					
	0					
	Р					
	Ø					
	R					
	S					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	w	
	х	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.